

Amendments to the Abstract:**Please rewrite the Abstract as follows:****ABSTRACT OF THE DISCLOSURE**

A piezoelectric/electrostrictive film type device ~~includes-is provided, including~~ a ceramic substrate ~~formed of a ceramic~~ and a piezoelectric/electrostrictive operation portion ~~in which~~including at least one piezoelectric/electrostrictive layer and at least one pair of electrodes electrically connected to the piezoelectric/electrostrictive layer that are stacked on the substrate. ~~In the device, an~~An outer surface of the piezoelectric/electrostrictive layer is subjected to surface modification to obtain a highly water repellent surface for inhibiting infiltration of moisture into micro-pores opened in the outer surface or into a gap between the substrate and the piezoelectric/electrostrictive layer. ~~The piezoelectric/ electrostrictive film type device has flexural displacement and durability equal to or more than those of a conventional piezoelectric/electrostrictive film type device and has a relatively high resonance frequency and is superior in high-speed response.~~